

Simoloyer[®] CM01-AB01/08

High Kinetic Processing mode

batch operation, auto-batch, semi-continuous

in general

High Kinetic Processing (HKP) in the Simoloyer[®] represents the most advanced technique for Mechanical Alloying (MA), High Energy (HEM) and Reactive Milling (RM), for making Nanostructures. To cover requirements from lab to industry for quality and quantity, processing modes batch-, auto-batch and semi-continuous operation do provide the most advanced solutions. While the Simoloyer[®] base unit remains same, grinding units are equipped with corresponding mainports. Standard for batch operation, type -s2 with second mainport for auto-batch and type -s1 with semi-continuous ports for insitu separation/classification at carrier-gas/multiphase flow. All types cover batch operation, multiple mainports are available up to type -s5 and exceeding.

application

Automatic batch-processing, for battery materials cathode, anode, particularly Li/Ion. ODS/NFA, both, Fe- and Ni-base manufacturing. Solid-state hydrogen storage, hard-metal applications, composite materials, rapid particle size reduction of brittle solids vs. ductile metal flakes and multiple more.

advance

large-scale semi-automatic nanostructure processing with aerodynamic separation. Here R/D nanostructures in/with:

- closed system, controlled atmosphere & evacuation;
- modular setup, automatic valves for system and charging;
- carrier-gas discharging with automatic product separation;
- communication of all drives by Maltoz[®]-software/PLC;

➤ safe process, faster discharging for best product quality.

data & dimensions AB(01)08-DN40

AB08 (CM01 > 1,5) IP22 upon inquiry: 230-528V	400VAC + PE, 3-phases (4 lines, TT/TN-net), 50/60Hz
power supply AB08 only	<5kW, 16A
dimensions (LxWxH)	1820 x 950 x 3700mm
floor-plan / AB08 weight	2 x 5m (10m ²) / 290kg

